# Geometrical effect of target crystal on PXR generation as a coherent X-ray source

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## **LEBRA facility at Nihon University**

#### LEBRA: Laboratory for Electron Beam Research & Application





Tunable light-source facility based on a conventional S-band electron linac

elctron energy: 125MeV(max.), 100MeV(typ.) average current :  $5\mu A$  (max.), 1 – 2  $\mu A$ (typ.)



## Beamlines of FEL & PXR



Free electron laser (FEL):  $1\mu m - 6\mu m$  (near-IR) Parametric X-ray radiation (PXR): 5keV - 20keV



#### Status of LEBRA-PXR

- \* Electron beam energy: 100MeV
- \* Macro pulse: ~100mA, 5 10μs, 2 5Hz
- \* Average current:  $1 5\mu A$
- \* Taget crystal: Si(111) plane
- \* PXR energy: 5 20keV
- \* Irradiation field: 10cm in diameter @ exit port
- \* Total flux:  $> 10^6 10^7$  photon/s
- \* Application: Dispersive XAFS (DXAFS) Diffraction enhanced imaging (DEI)



## Typical result of DEI (symm.target)



![](_page_4_Picture_2.jpeg)

#### Measurement for spatial coherence

![](_page_5_Figure_1.jpeg)

![](_page_5_Picture_2.jpeg)

#### Edge effect of the target crystal

![](_page_6_Figure_1.jpeg)

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#### Asymmetric cut target (arrgt.1)

![](_page_7_Figure_1.jpeg)

#### In this arrangement,

- \* electron path < X-ray path on the asymmetric surface
  - -> Intensity of PXR from front surface is much reduced
- \* Front and rear surfaces are invisible from 2θ direction at 17.5keV. (Bragg angle = 6.5 deg.)

![](_page_7_Picture_6.jpeg)

### Rocking curve of 2nd crystal (arrgt.1)

![](_page_8_Figure_1.jpeg)

symmetric surface > asymmetric surface

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\* 2nd crystal angles are slightly different.

## Results in arrgt.1 (Imaging)

![](_page_9_Figure_1.jpeg)

Horizontal image doublet is substantially suppressed and the edge is well defined at 17.5keV. (edge irradiation)

#### IP: 30min

![](_page_9_Figure_4.jpeg)

#### e-beam size (H1.5 x V1.5mm)

Propagation distance: 220cm

![](_page_9_Picture_7.jpeg)

#### Energy resolution of DXAFS measurement

![](_page_10_Figure_1.jpeg)

DXAFS resolution depends on the horizontal source size. Resolution of spectra ~ 3eV, corresponding to 0.6mm

![](_page_10_Picture_3.jpeg)

PXR

#### Asymmetric cut target (arrgt.2)

![](_page_11_Figure_1.jpeg)

Front surface: asymmetric cut

Rear knife-edge surface: symmetric Bragg case

#### In this arrangement,

- X-ray path < electron path on the asymmetric surface</li>
  -> Absorption of PXR is reduced
- \* Only front asymmetric surface is visible from 2θ direction

![](_page_11_Picture_7.jpeg)

## Absorption imaging in arrgt.2

![](_page_12_Picture_1.jpeg)

IC card@14keV e-beam: 100mA, 5μs, 5Hz (2.5μA) exposure: 30s (macro-pulse duty: 0.75ms)

#### In this arrangement,

- PXR intensity rather improves, even if the e-beam is wider than the surface of the target crystal.
- Imaging with shorter exposure is possible.
  (Flux > 10<sup>7</sup> /s)

![](_page_12_Figure_6.jpeg)

### Absorption imaging in arrgt.2

PXR: 16keV

![](_page_13_Picture_2.jpeg)

![](_page_13_Picture_3.jpeg)

## Edge effect of the target crystal

![](_page_14_Figure_1.jpeg)

![](_page_14_Picture_2.jpeg)

![](_page_14_Picture_3.jpeg)

![](_page_14_Picture_4.jpeg)

same e-beam size (H1.0 x V2.5mm) Propagation distance: 220cm

The doublet of the image due to the edge effect is enhanced.

Two coherent X-ray beams maybe exist.

![](_page_14_Picture_8.jpeg)

#### Edge effect of the target crystal

![](_page_15_Figure_1.jpeg)

## Diffraction enhanced imaging (DEI) in arrgt.2

![](_page_16_Figure_1.jpeg)

#### In this arrangement,

- \* DEI is also possible
- \* relatively short exposure time
- \* phase accuracy may be worse (possibly)

![](_page_16_Picture_6.jpeg)

![](_page_16_Picture_7.jpeg)

### Summary

- Mainly the knife-edge surface in a symmetric Bragg case contributes PXR emission.
- \* The edge effect disappears.
- \* The spatial coherence and the spectral resolution tend to improve.
- The intensity becomes rather weak.
  The contribution from the deep volume in the target seems to be little.

![](_page_17_Figure_5.jpeg)

![](_page_17_Picture_6.jpeg)

#### Summary

\* The intensity rather improves and imaging with shorter exposure is possible.

- \* The edge effect seems to be enhanced.
- DEI is possible.
  It indicates that the use of asymmetric cut surface dose not destroy the coherence of PXR.

![](_page_18_Picture_4.jpeg)

![](_page_18_Picture_5.jpeg)

## Acknowledgments

 The "Academic Frontier" Project for Private University: matching fund subsidy from MEXT, 2000-2004 & 2005-2007

Thank you for your kind attention !!

![](_page_19_Picture_3.jpeg)

## Appendix

![](_page_20_Picture_1.jpeg)

## Results in arrgt.1 (Imaging)

![](_page_21_Figure_1.jpeg)

Horizontal image doublet was strongly suppressed and the edge was well defined at 17.5keV. (edge irradiation)

#### e-beam size (H1.5 x V0.7mm)

![](_page_21_Picture_4.jpeg)

## Diffraction enhanced imaging (DEI) in arrgt.1

![](_page_22_Figure_1.jpeg)

Longer exposure time is necessary.

![](_page_22_Picture_3.jpeg)

![](_page_22_Picture_4.jpeg)

#### Absorption imaging

![](_page_23_Picture_1.jpeg)

laser pointer@16.0keV average current: 2.2 μ A exposure: 10s (IP) calculator@16.0keV average current:  $1.2 \mu$  A exposure: 30s (IP)

![](_page_23_Picture_5.jpeg)

#### Absorption imaging

![](_page_24_Picture_1.jpeg)

laser pointer@16.0keV average current:  $2.5 \mu$  A exposure: 180s (IP)

![](_page_24_Picture_3.jpeg)

#### Edge effect of the target crystal

![](_page_25_Figure_1.jpeg)

![](_page_25_Picture_2.jpeg)

![](_page_26_Figure_0.jpeg)

![](_page_26_Picture_1.jpeg)

#### Simultaneous imaging by 2color beams

![](_page_27_Figure_1.jpeg)

![](_page_27_Picture_2.jpeg)

Cu can be detected!

![](_page_27_Picture_4.jpeg)

#### EXAFS analysis using PXR-DXAFS

![](_page_28_Figure_1.jpeg)

![](_page_28_Picture_2.jpeg)